



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

CPS/2815  
#15

In re the Application of: Kiyoshi IRINO

Serial Number: 09/428,052

Group Art Unit: 2815

Filed: October 27, 1999

Examiner: R. Diaz 1-23-02

For: METHOD OF FABRICATING A SEMICONDUCTOR DEVICE CONTAINING NITROGEN IN A GATE OXIDE FILM T. Flower

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
Washington, D.C. 20231

January 9, 2002

Sir:

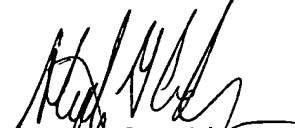
Applicant petitions the Commissioner of Patents and Trademarks to extend the time for response to the Office Action dated August 9, 2001, for two months from November 9, 2001 to January 9, 2002.

Attached please find a check in the amount of \$400.00 to cover the cost of the extension. In the event that any additional fees are due in connection with this paper, please charge our deposit Account No. 01-2340. This paper is filed in triplicate.

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Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP

  
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Atty. Docket No. 970901A

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